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U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
/RB/	2002	0 1 0 2 8 2 6A1	8/2002	Shimamoto et al.	438	575	
/RB/		6 0 7 4 9 4 5	6/2000	Vaartstra et al.	438	681	
/RB/		6 4 4 0 4 9 5B1	8/2002	Wade et al.	427	250	

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No

Other Documents (including Author, Title, Date, Pertinent Pages, Etc.)

/RB/		Peck et al., "Chemical Vapor Deposition Of Novel Precursors For Advanced Capacitor Electrodes", Electrochemical Society, Inc. published and presented on 5/14/02

Examiner	/Renee Berry/	Date Considered	06/20/2007

* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant